

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 5, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG797653252

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.35 - 6.39 X 4.00 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.00 CARAT

E

VS 1

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

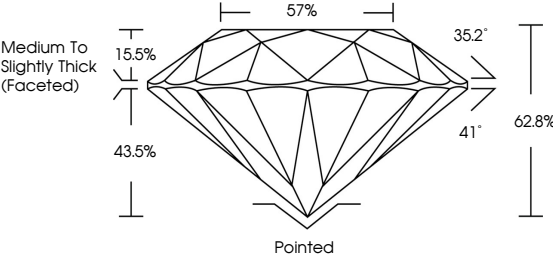
EXCELLENT

NONE

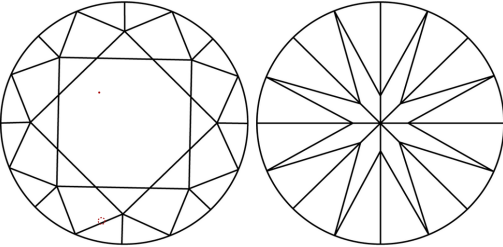
 LG797653252

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS

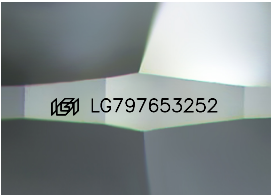


KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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EXCELLENT

EXCELLENT

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ROUND BRILLIANT

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Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.00 CARAT

E

VS 1

EXCELLENT

62.8%

57%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG797653252

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